

DE LA RECHERCHE À L'INDUSTRIE

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PROGRESS AND STATUS ON ESS MEDIUM BETA PROTOTYPE CAVITIES AT CEA

E. Cenni on behalf of cavities work unit

7th SLHiPP meeting Orsay 2017

CEA Saclay/ESS ECCTD WU Cavités | Enrico Cenni



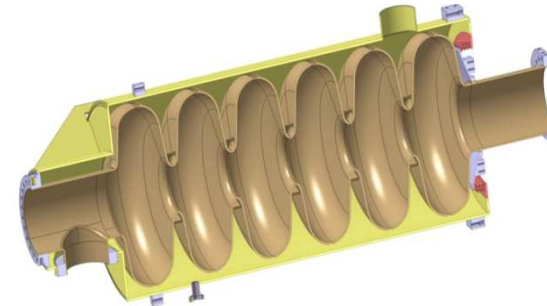
OUTLINE

- **Manufacturing and preparation**
 - Shape control
 - RF measure
 - Heat treatment
 - Final BCP
- **Latest results**
 - Surface resistance
 - Q-E curves
 - X-ray measures
 - 100K parking
 - LFD
 - Tuning sensitivity
 - Magnetic shielding
- **Cavities status**
- **Lessons learned**
- **Summary and outlook**

DESIGN



LUND
UNIVERSITY



MANUFACTURING



PREPARATION AND TEST

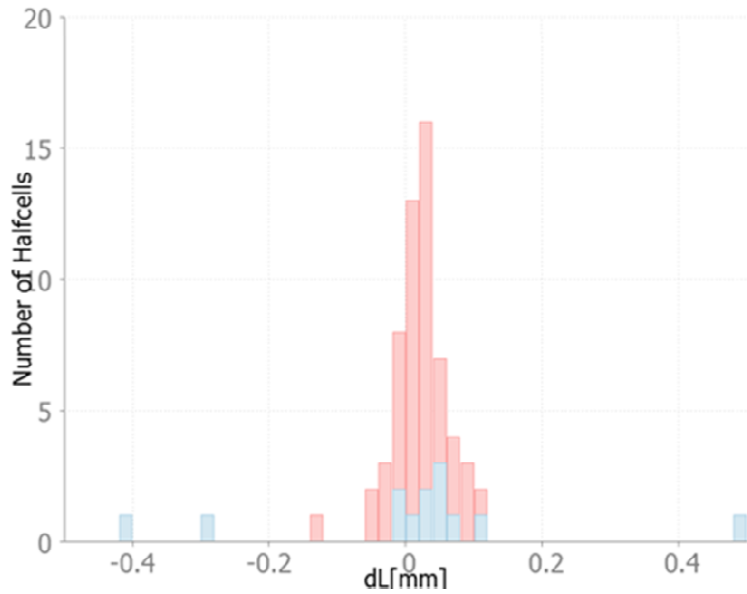


M-ECCTD will be equipped with **3 cavities from CEA** and **1 cavity from INFN-LASA**

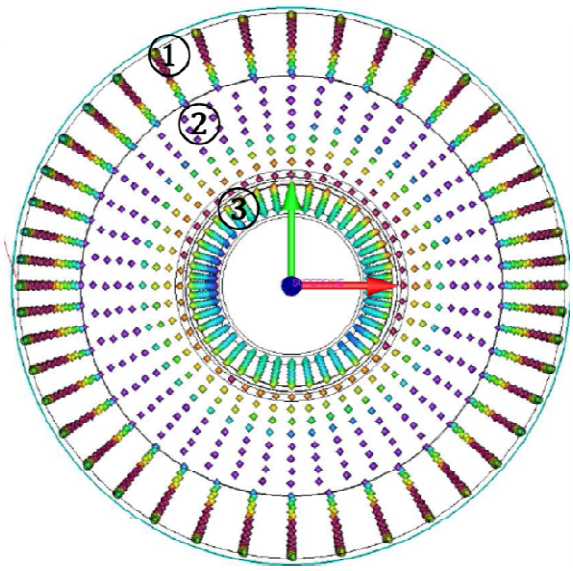
This talk will be about the work done in CEA concerning medium beta prototypes



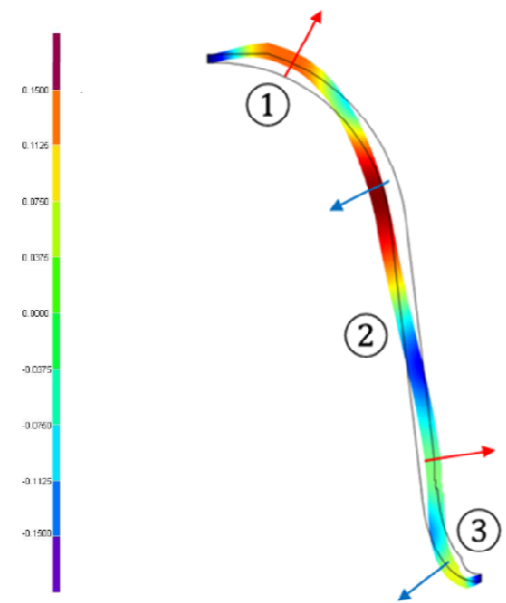
Manufacturing



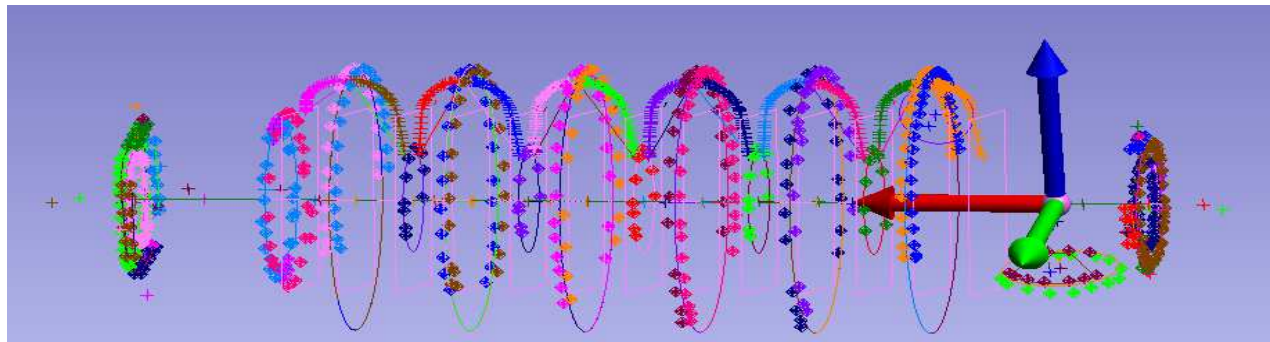
Length difference between ideal and measured values on central group (red) and end group (blue) halfcells, each bin has 0.02mm width.



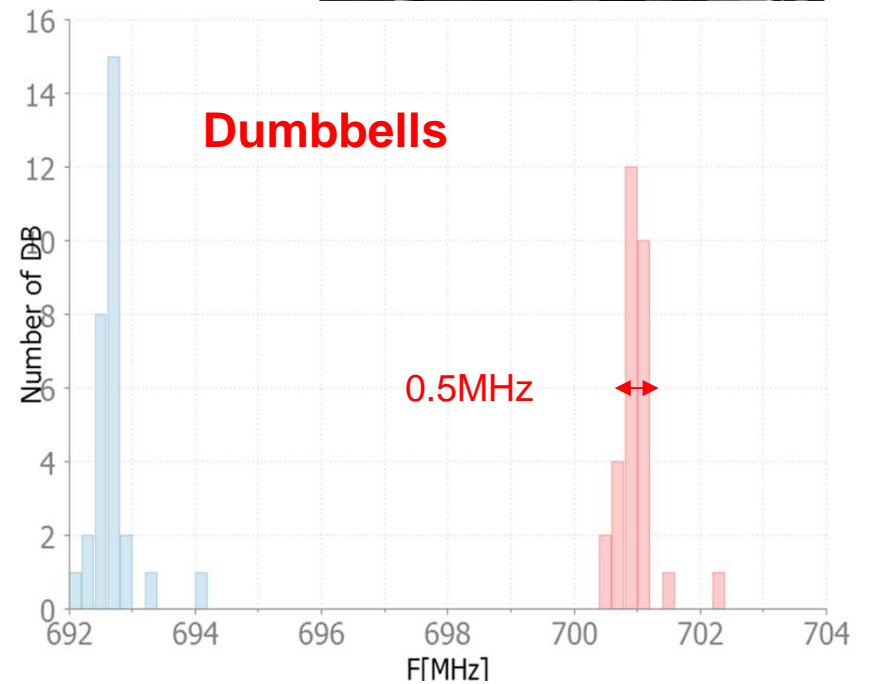
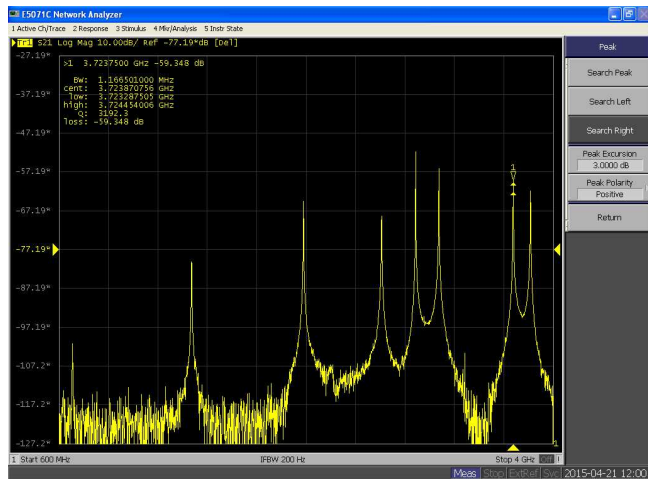
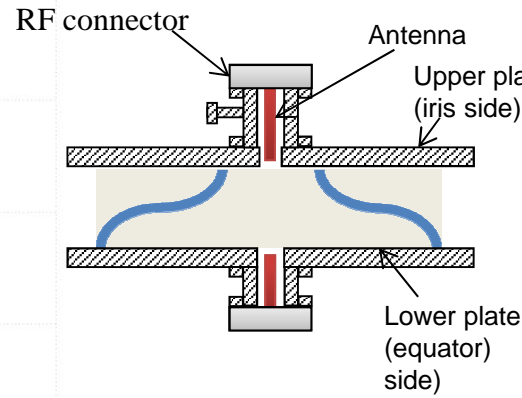
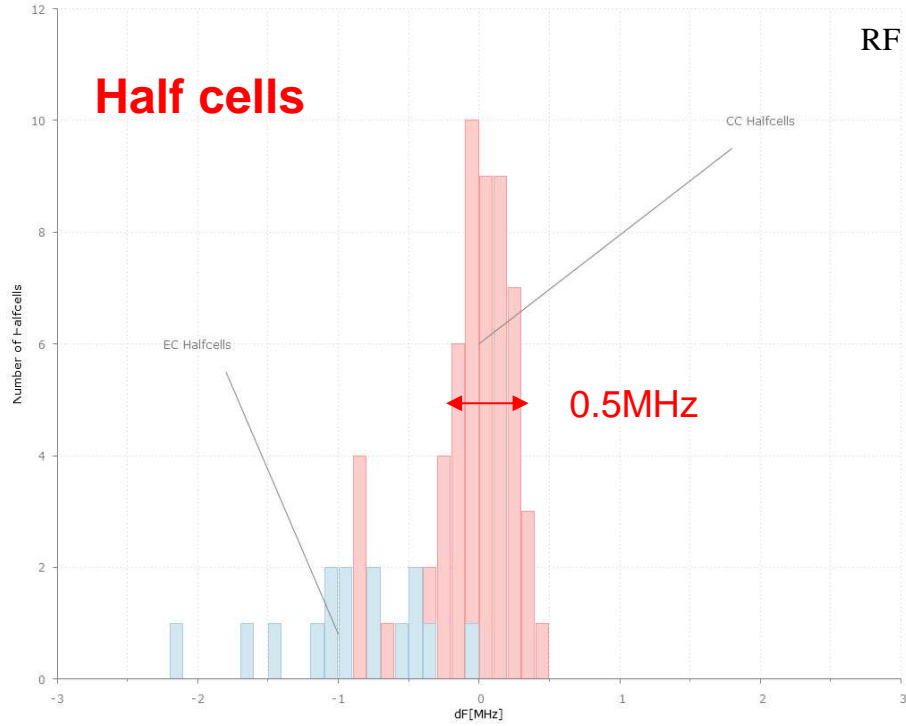
3D CMM result on a central half cell, red +0.15mm, purple -0.15mm (shape tolerance 0.3).



Sketch of average deformation observed on central half cell not in scale.



Laser tracking 3D measure performed at CEA

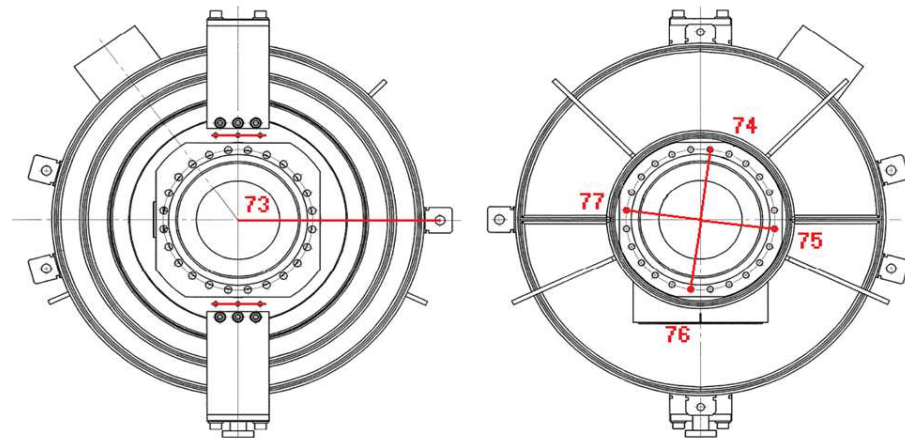
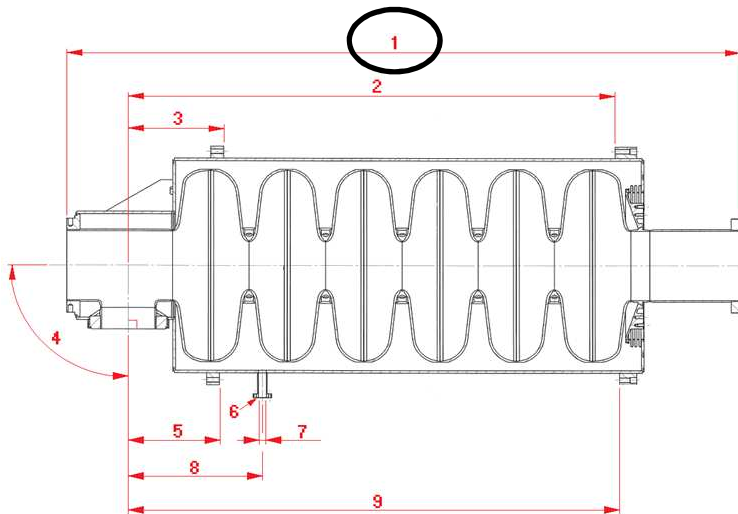


We have created a dimension control plan on each subparts

- 300 points on each halfcells and dumbbells by means of CMM
- On the integrated cavity we put about 80 dimensional controls (this will be optimized after string assembly feedback)

Some number related to the first 4 integrated cavities:

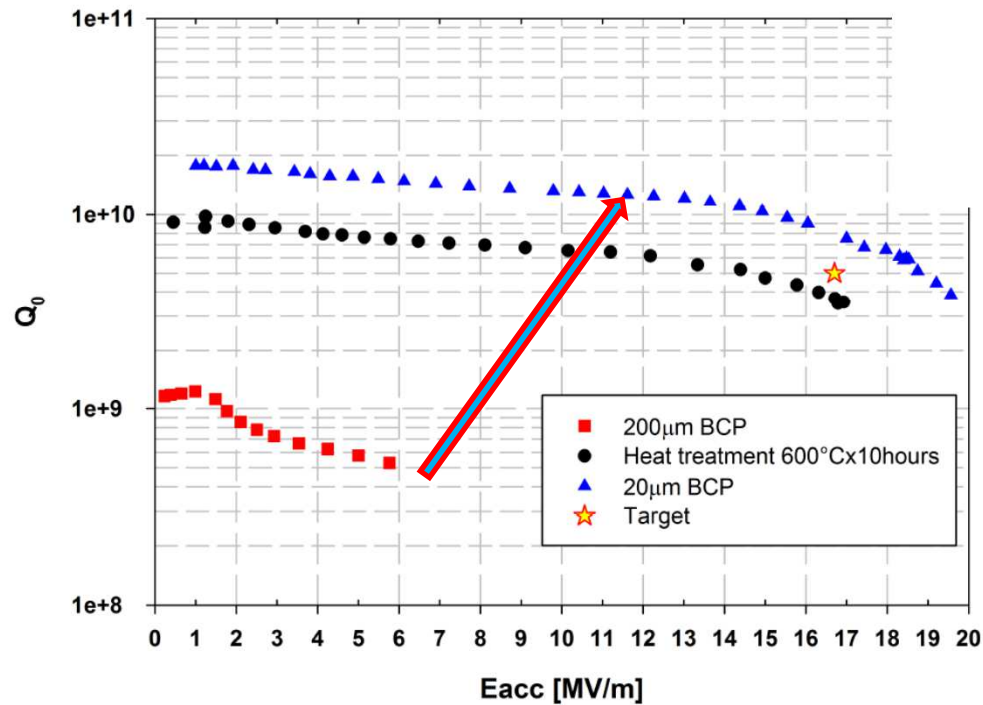
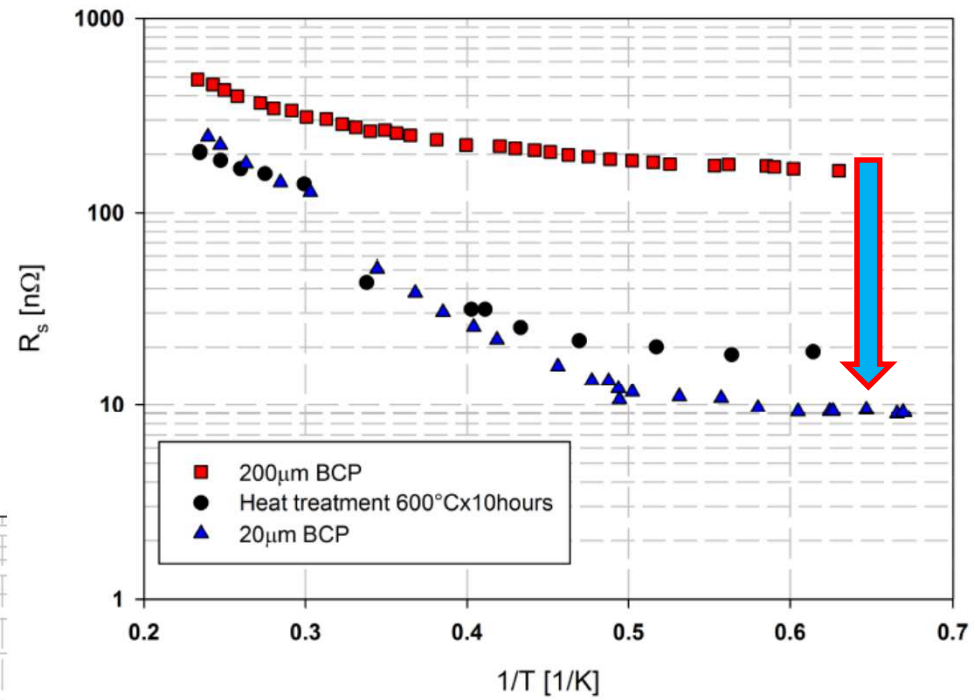
- Maximum displacement between beam flanges 1mm (average is 0.6mm)
- Maximum angular displacement 0.5° (average is 0.2°)

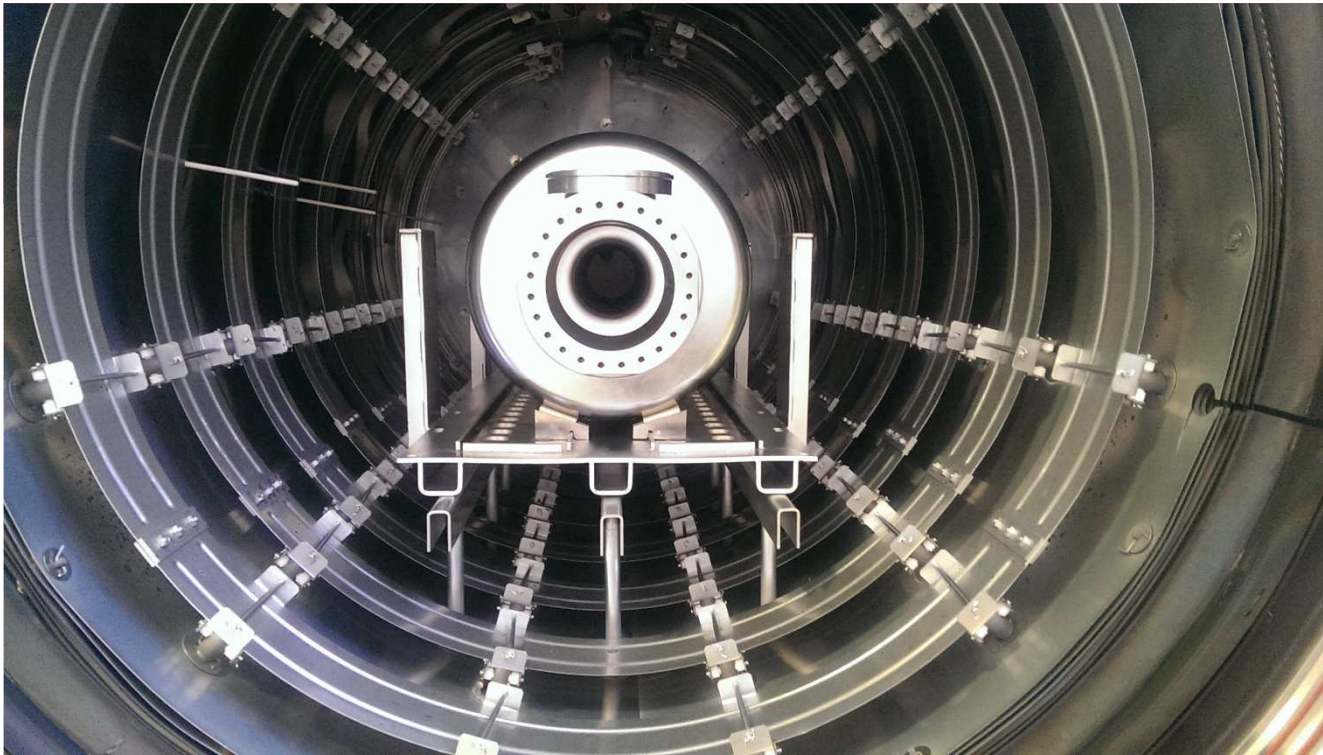




Measures and results

Process	Rs @2K [nΩ]
BCP (~200μm)	~200
Heat treatment+HPR	~20
BCP(~20μm)+HPR	~10





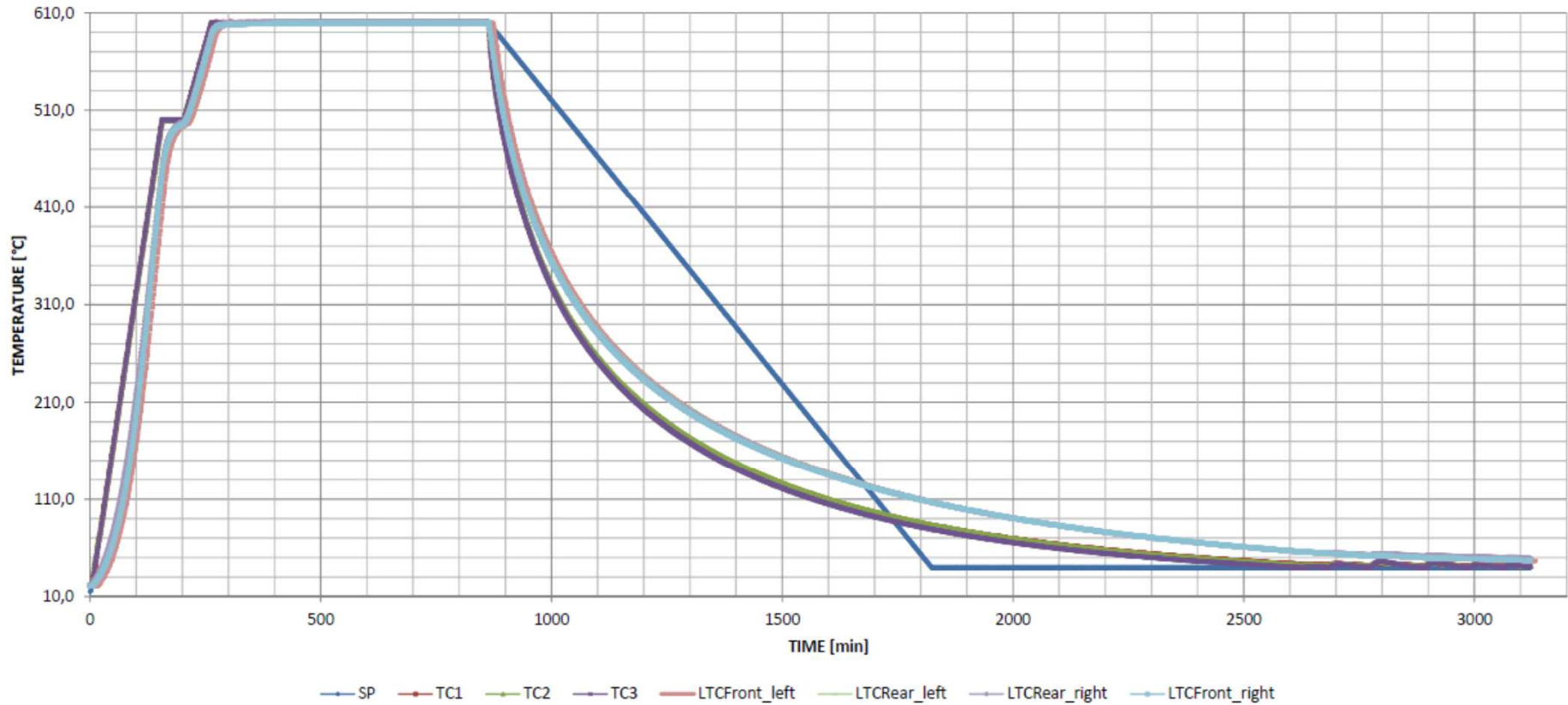
Zanon

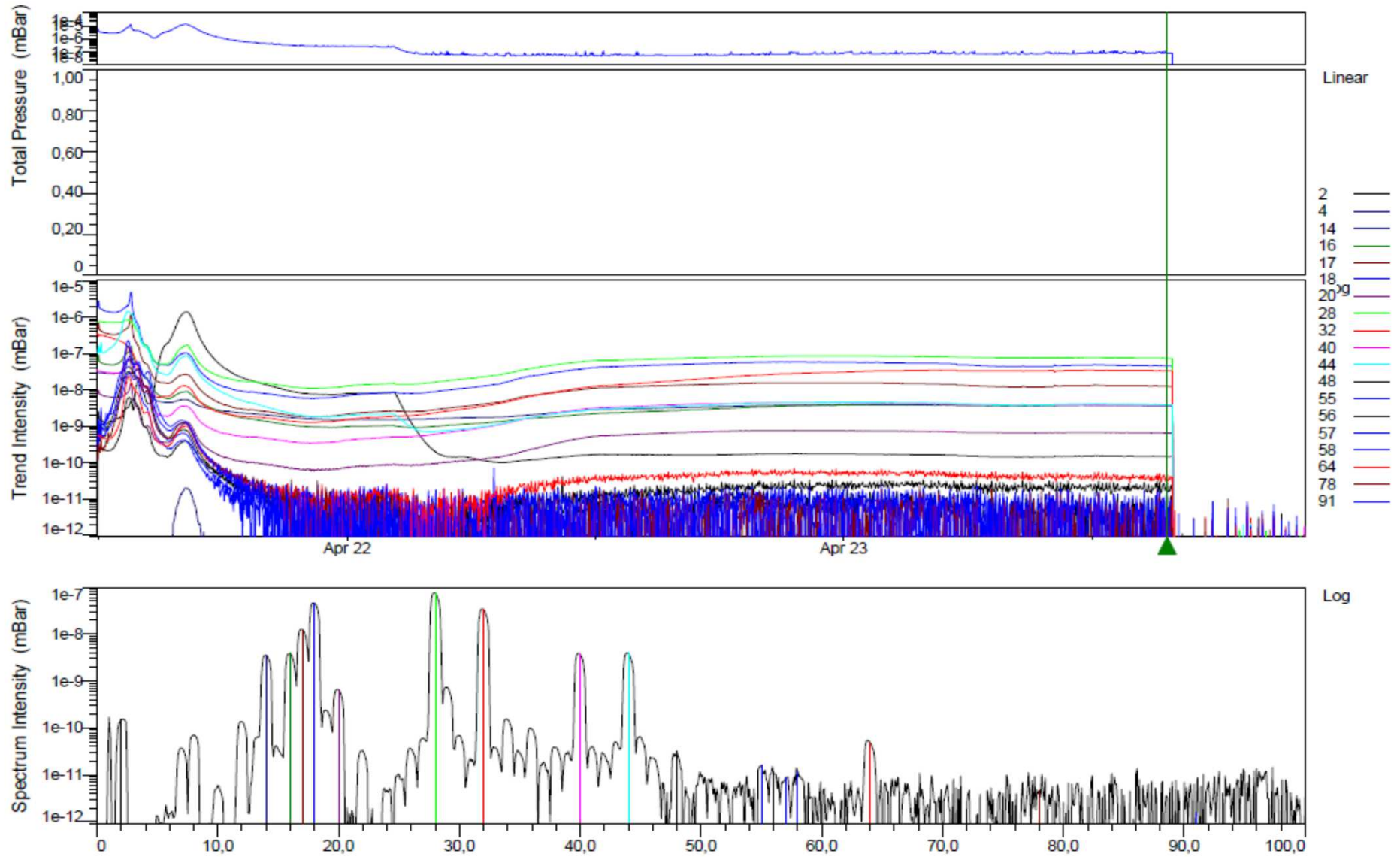


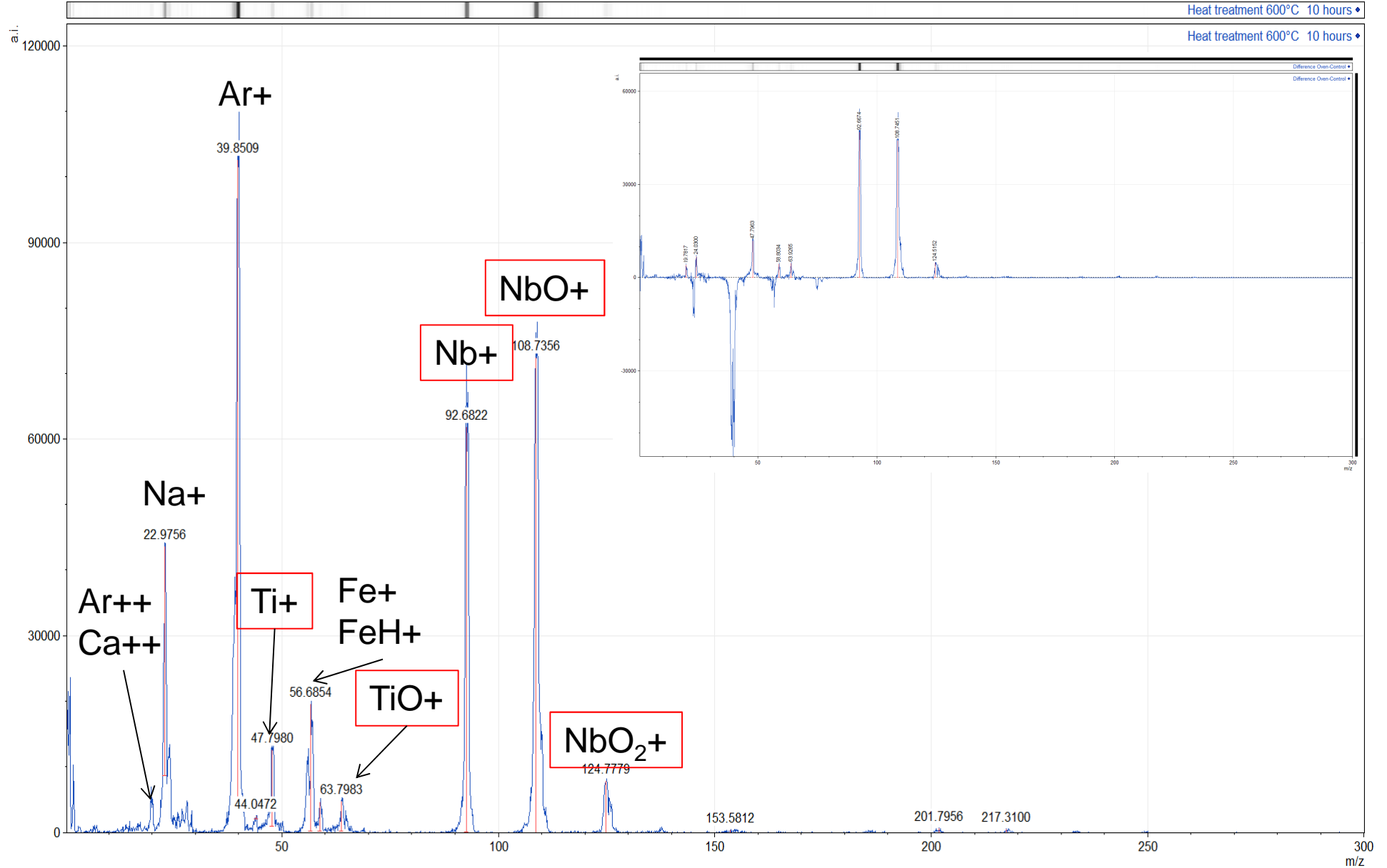
First shield and heating system made with Molybdenum. Same oven used for XFEL and LCLS2

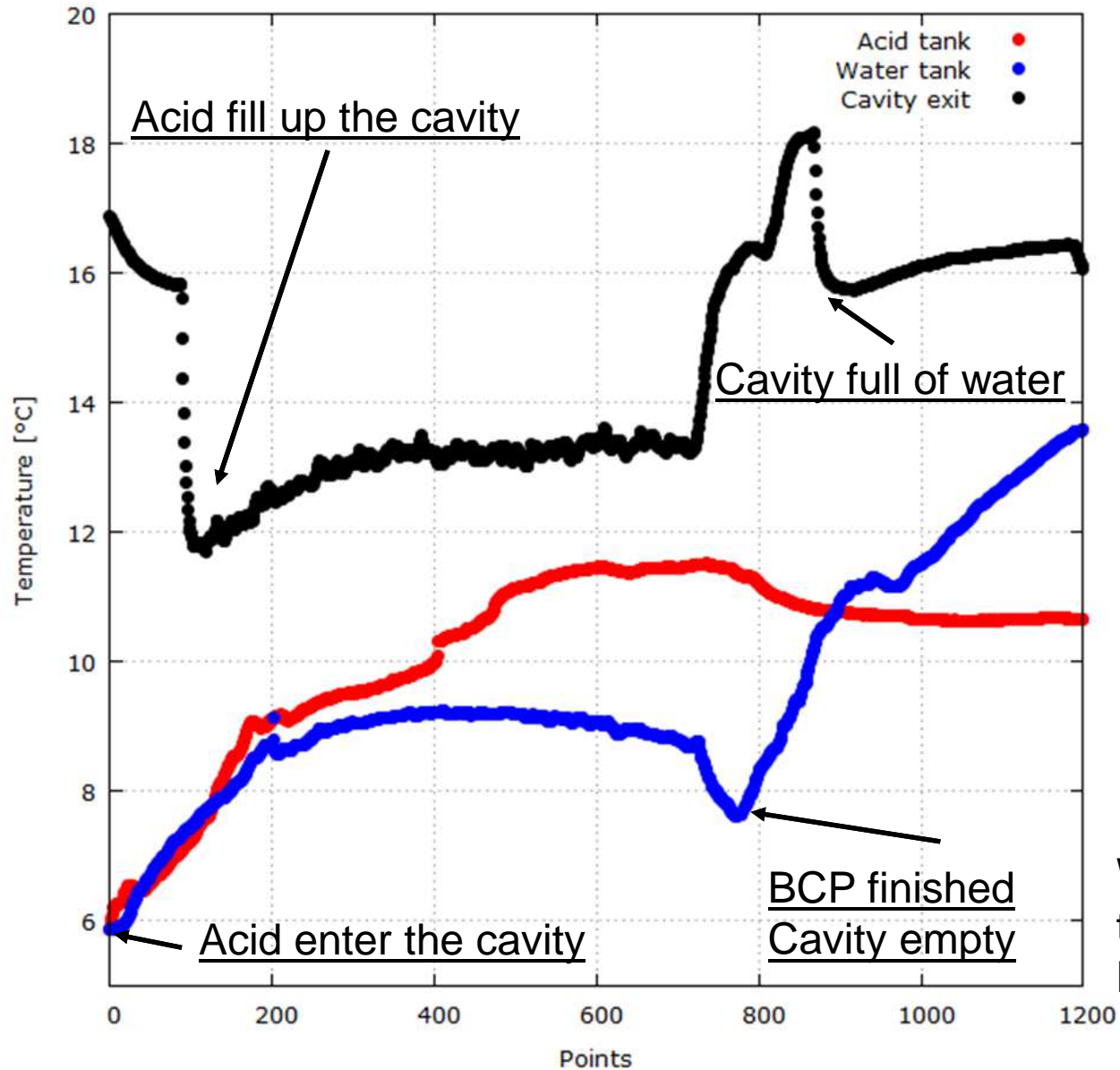


2016_04_26 CAV01_EZ_ESS_MR_temperature

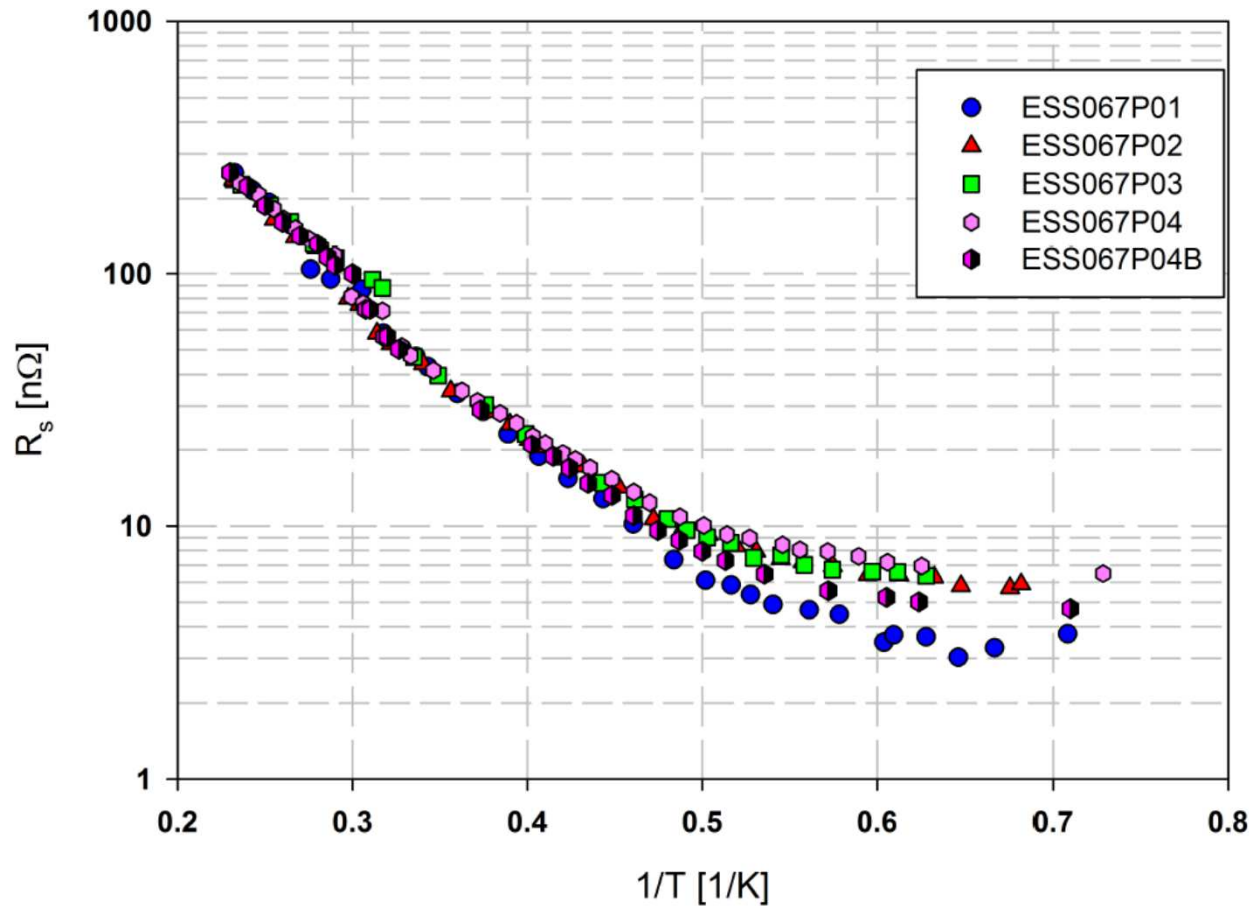








We are able to limit the temperature increase during BCP.



We were able to obtain good surface resistance on all cavities.
BCP process has been strongly improved

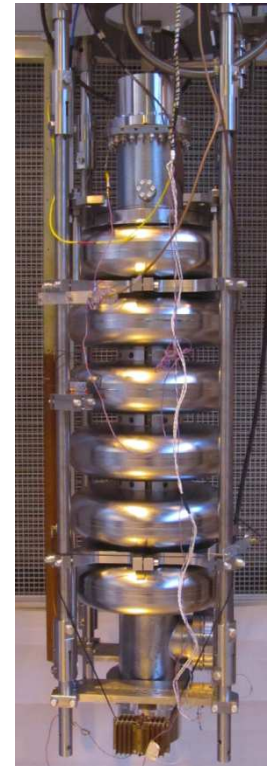
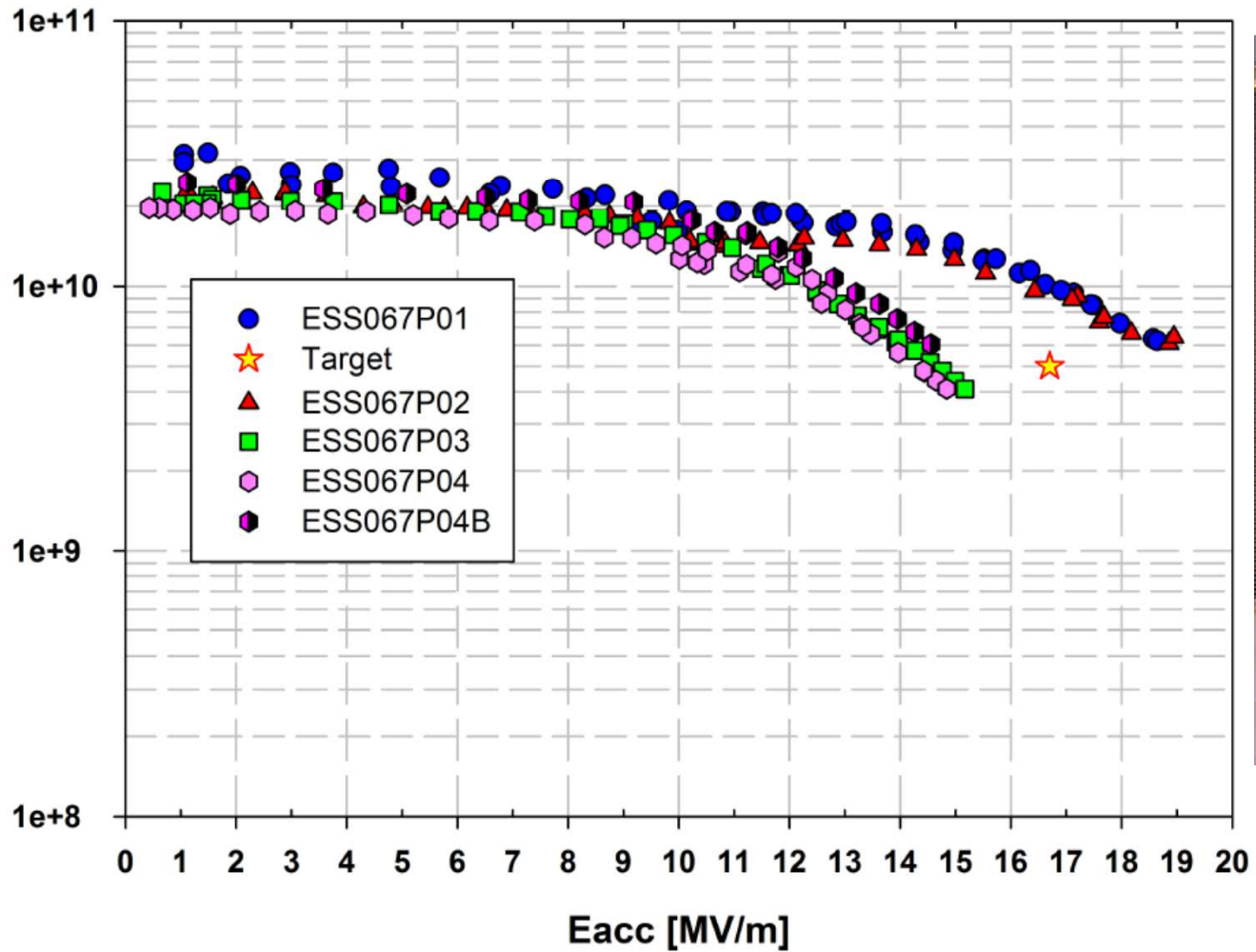
Data fitted with

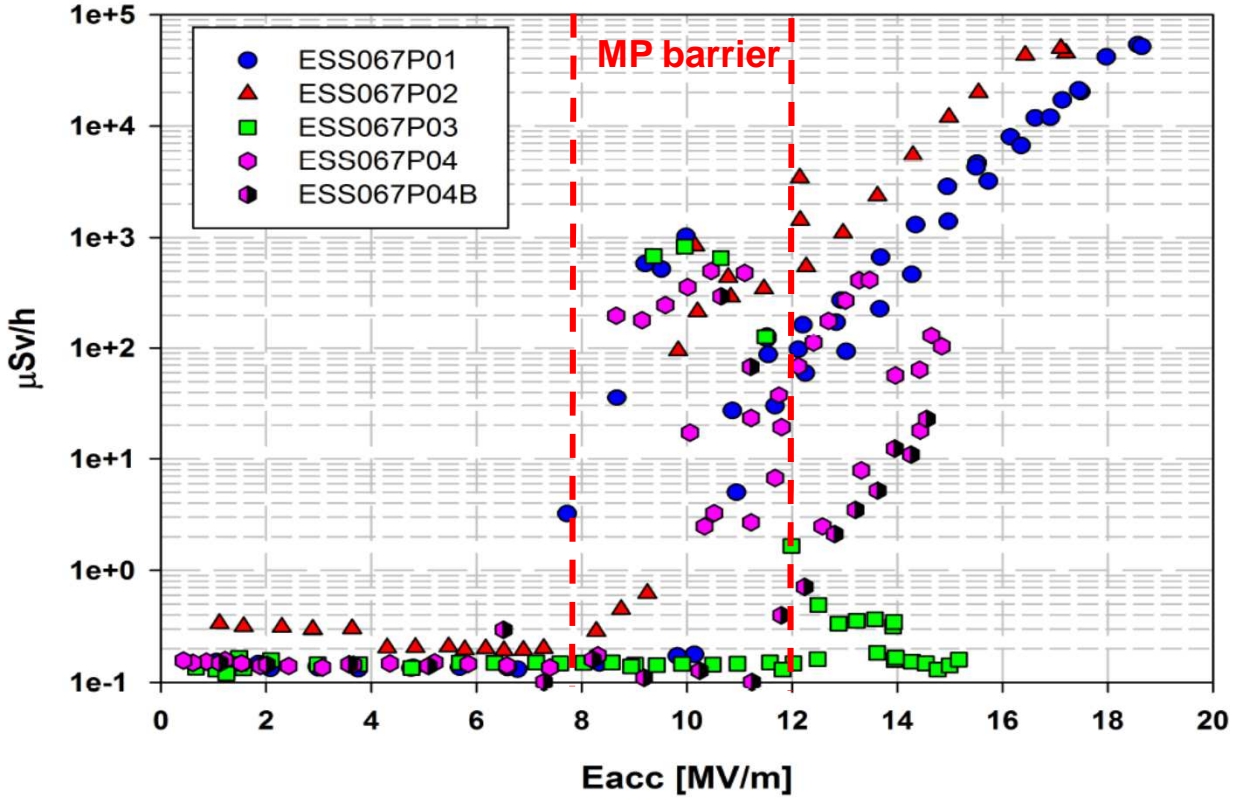
$$R_S = \frac{A}{T} \times e^{-\frac{\Delta}{T}} + R_0$$

Cavity serial number	Residual resistance (R_0) [nΩ]	Q0 at 1MV/m @2K
MP01	3.14	3.2×10^{10}
MP02	6.09	2.2×10^{10}
MP03	6.06	2.1×10^{10}
MP04	7.09	1.9×10^{10}
MP04 (b)	4.85	2.5×10^{10}

$Q_0(2K)$ at low field is $\geq 1.9 \times 10^{10}$ for all cavities

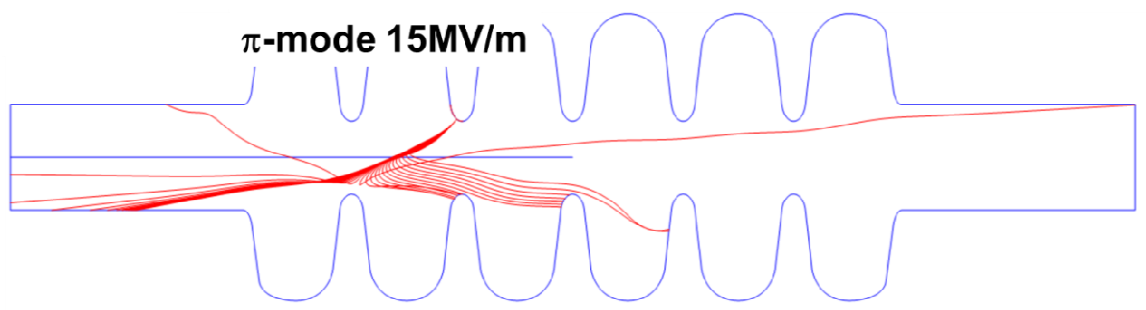
Vertical test ESS medium beta prototypes with tank (CW mode @2K)



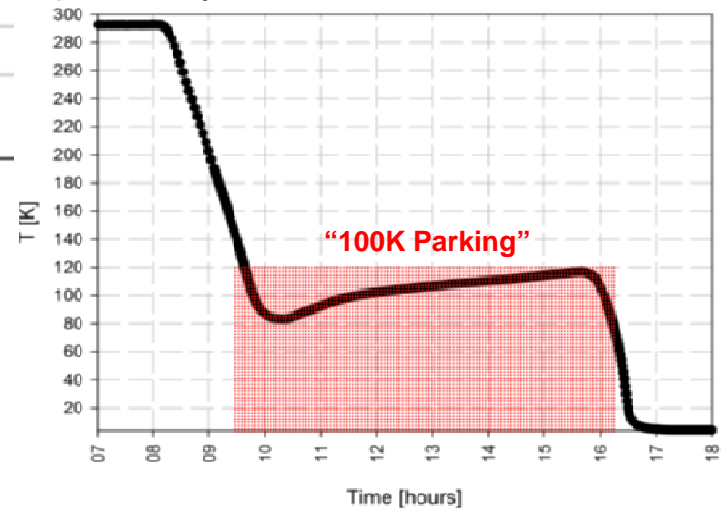
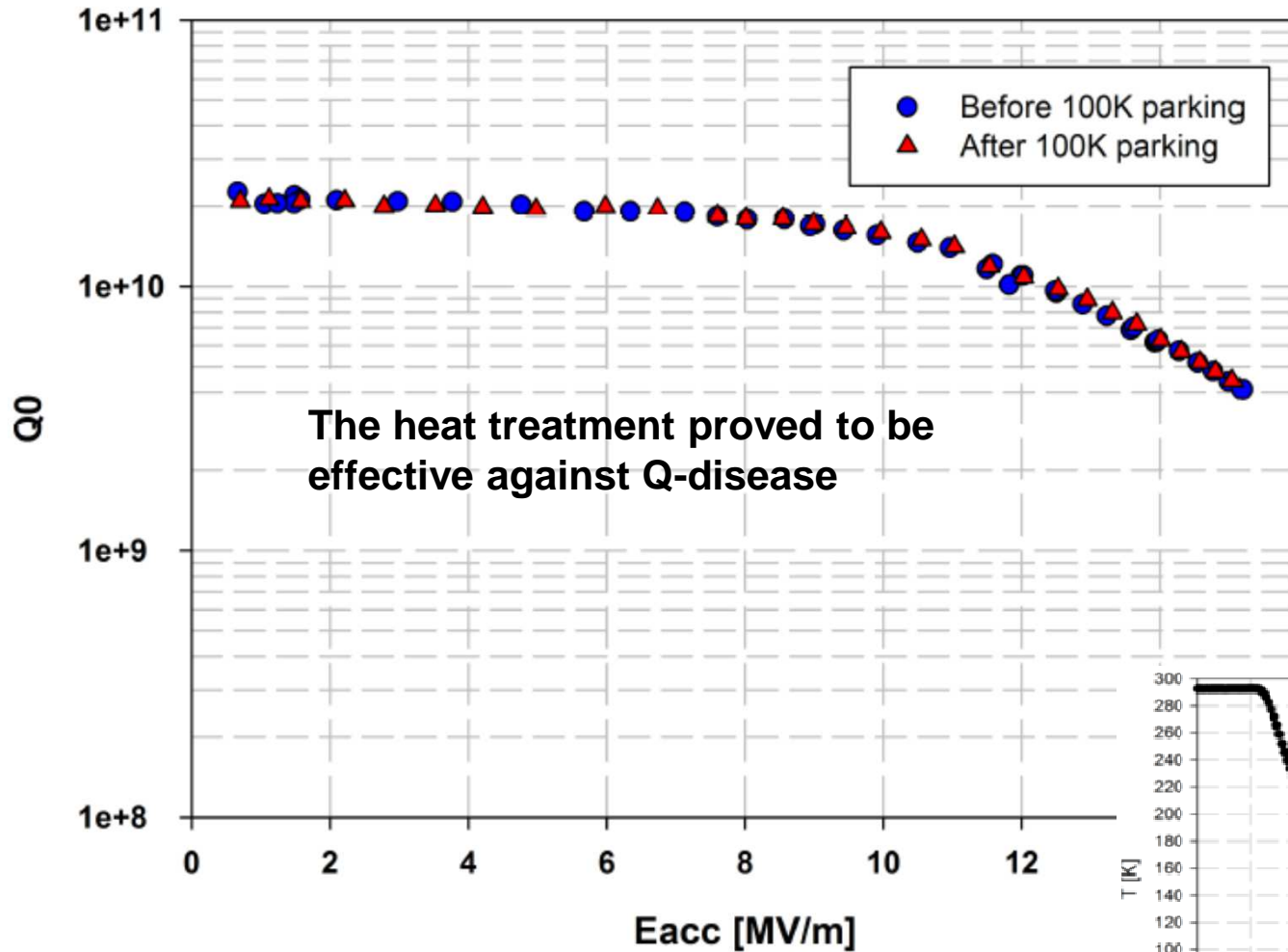


NaI(Tl) scintillator

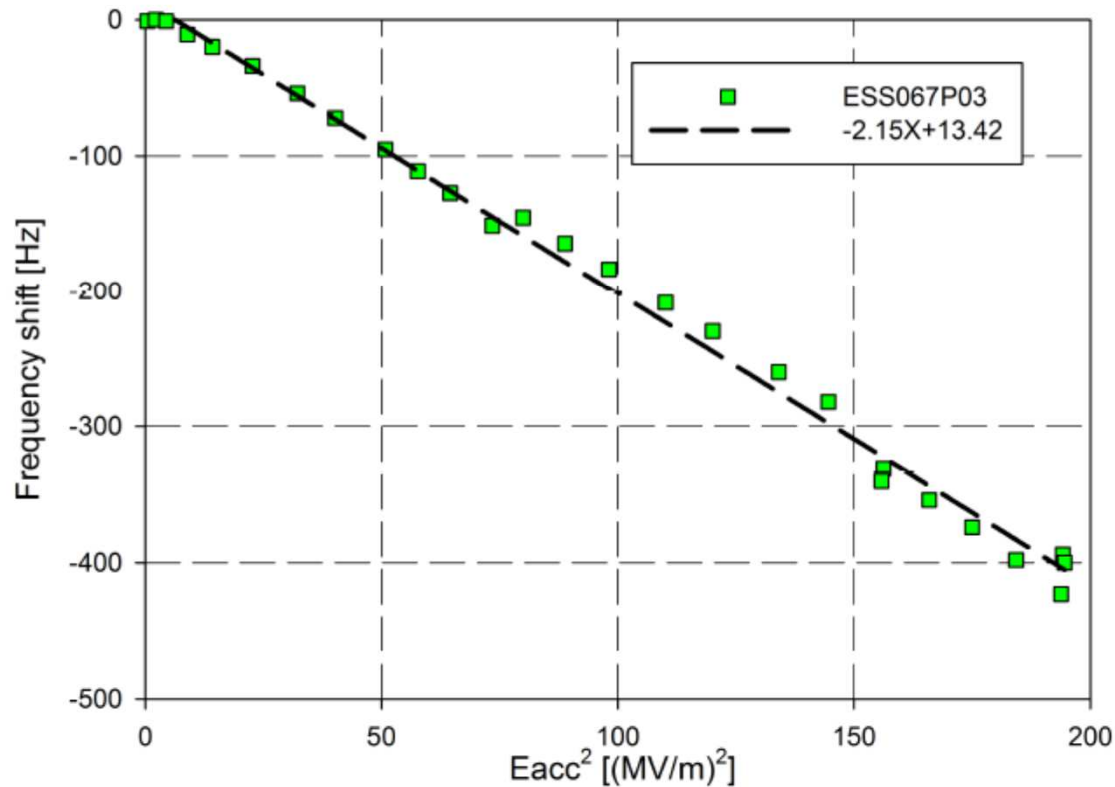
We plan to implement systematic x-ray spectra recording on vertical cryostat and cryomodule.



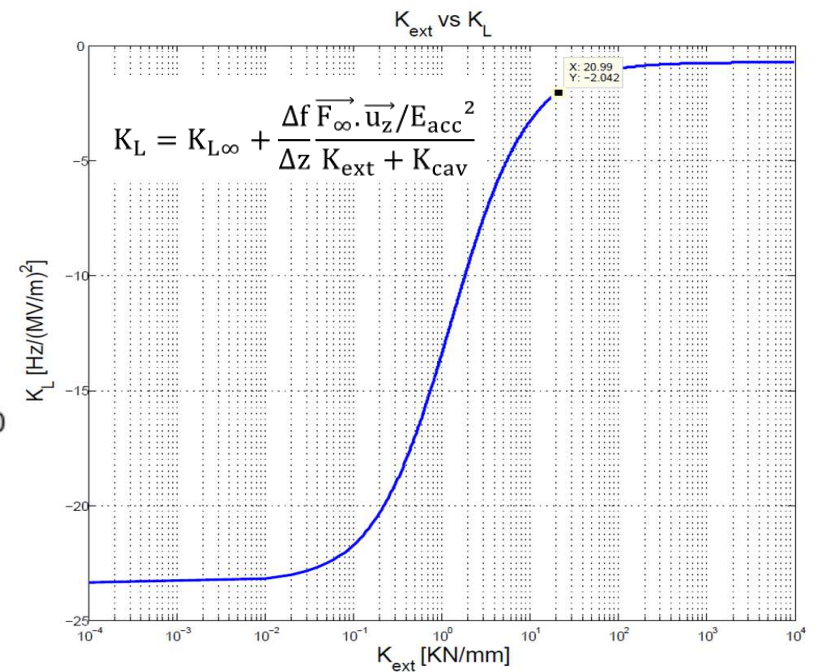
Cavity serial number	X-ray dose rate at ~15MV/m (π -mode) [mSv/h]
MP01	2.8
MP02	18.6
MP03	0.0002 (background)
MP04	0.1
MP04 (b)	0.022

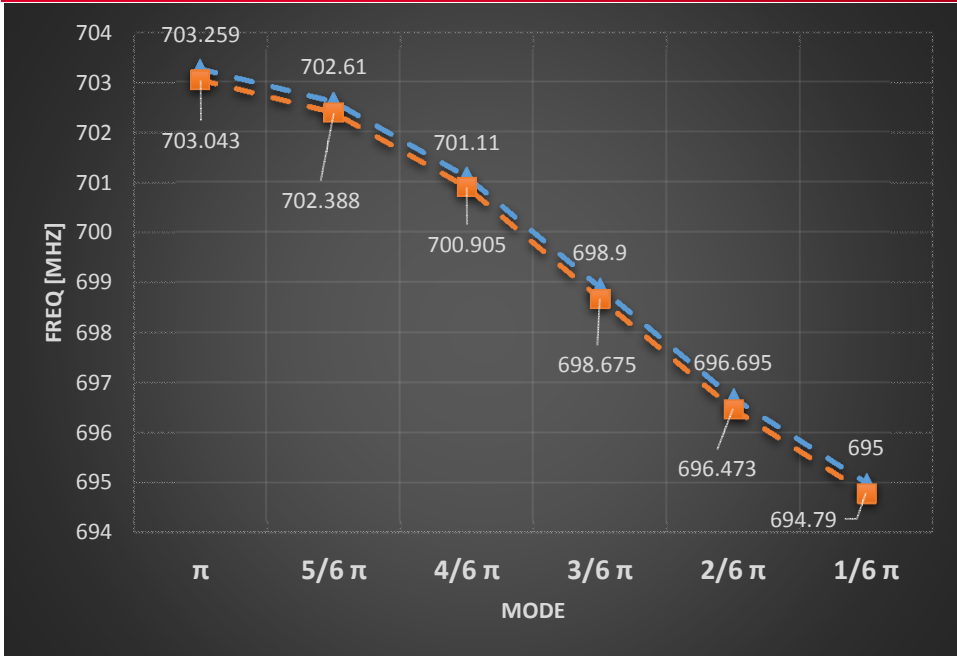


Lorentz force detuning
(CW @2K)
Tuner mounted on cavity (preload 10 turns)



The measure is consistent with calculation





Passband mode frequencies in vacuum while moving the tuner

Blue 10 turns pull (~1mm)

Orange 0 turn (blocked before pumping)



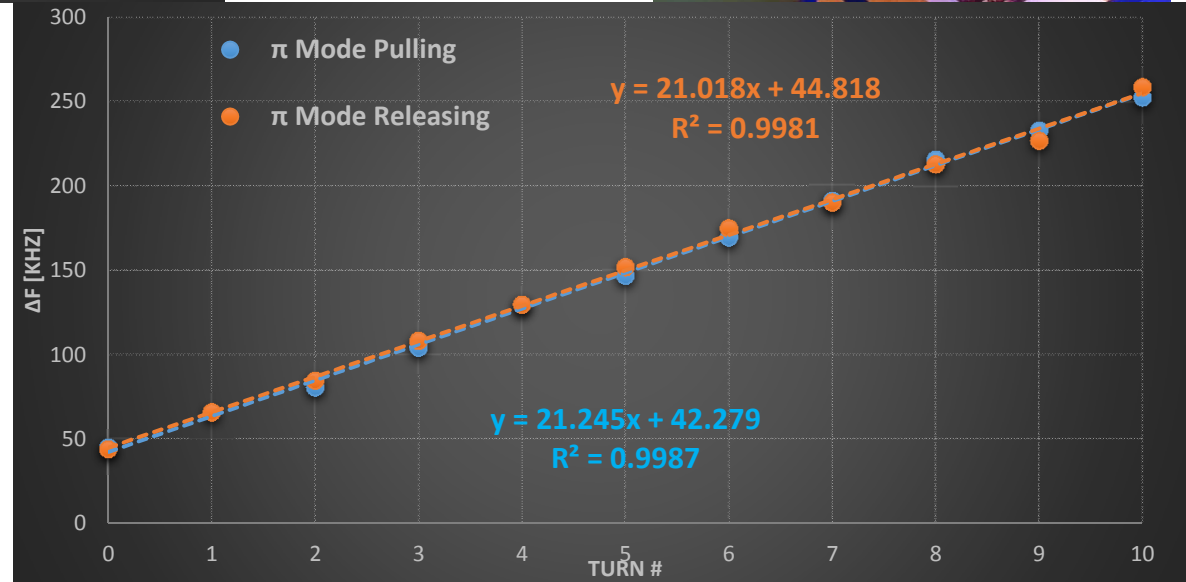
Tuning sensitivity:

Pulling

Releasing

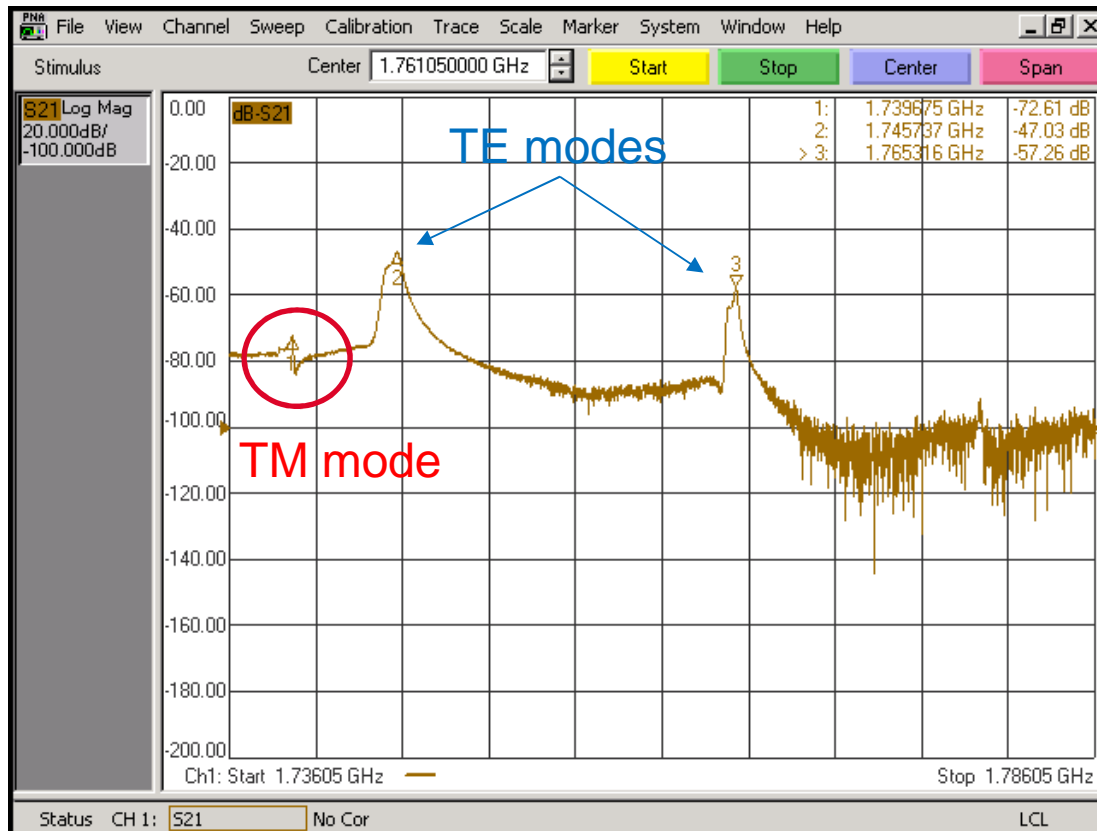
No backlash

Computation predict 211kHz/mm
measured value is between 210-212 kHz/mm

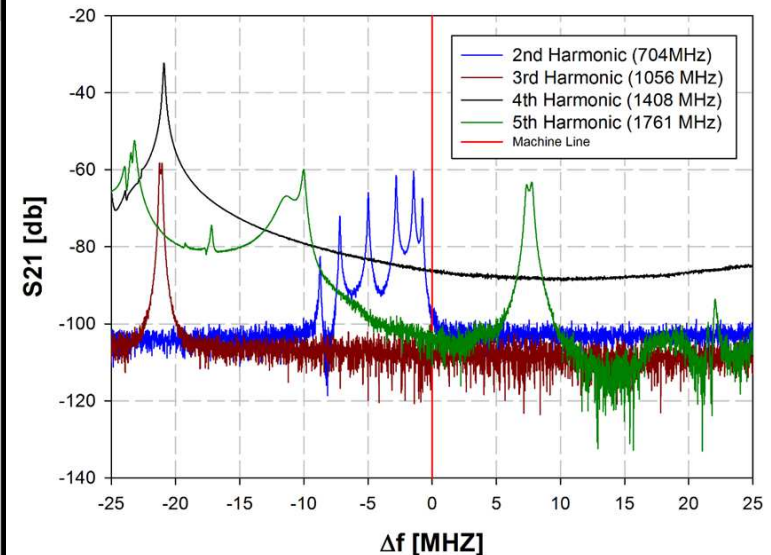


Cavity Field flatness are consistently brought to 95%, heat treatment and tank integration can change the field flatness about 1-2% depending on the accumulated stress on the cavity.

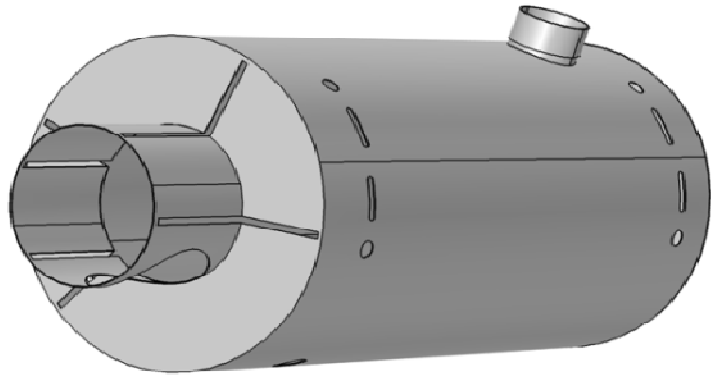
HOMs are monitored during manufacturing and they are away from machine lines as designed (typically more than 20MHz)



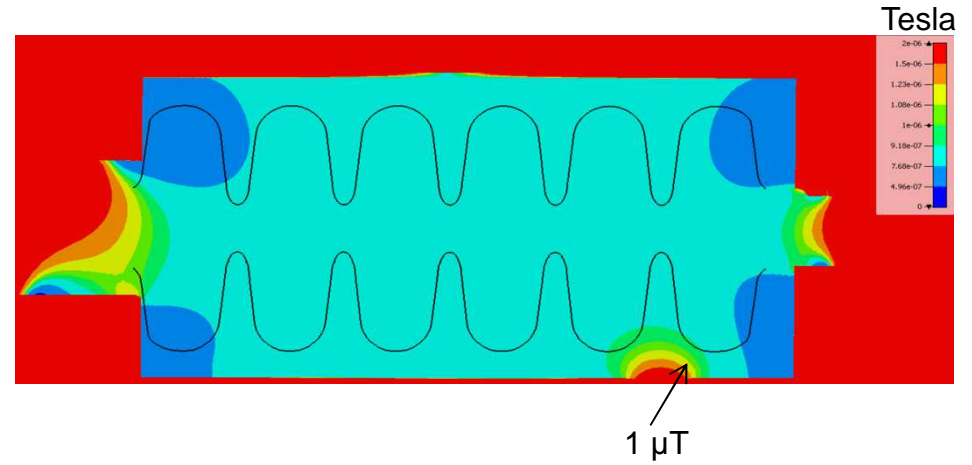
S21 Measure
Medium-β pre-tuning results



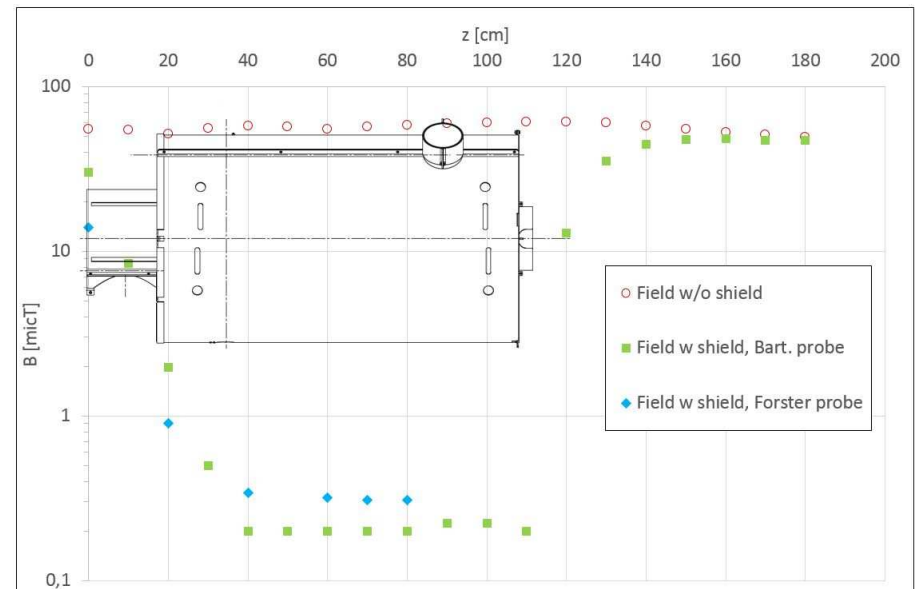
Note: each BCP moves the dangerous TM mode more away from machine line



Requirements: maximal field around cavity $< 2 \mu\text{T}$



Field is lower than $1 \mu\text{T}$ inside the shield, and mainly around $0,5 \mu\text{T}$
 We are confident for a value $< 2 \mu\text{T}$ at cold temperature



Cavities	Status	Details
MP01	Assembled on the string	
MP02	Assembled on the string	
MP03	Assembled on the string	
MP04	Equipped with tank	R&D
MP05	Naked	R&D
MP06	Naked 200µm BCP performed at Zanon	R&D

- ✓ Manufacturing process looks to be reproducible and reliable (learning curve shall be taken into account), still there is space for improvement
- ✓ BCP temperature shall be monitored, water cooling proof to be effective with integrated cavity (recently we were able to obtain very low R_s)
- ✓ Frequency change rate with BCP is about $2.9\text{kHz}/\mu\text{m}$ and the average etching rate is about $1\mu\text{m}/\text{min}$ with 1:1:2.4 mix (FNP), in good agreement with simulation
- ✓ Heat treatment at 600°C for 10 hours works fine (no Q-disease has been observed)

- We have successfully manufactured 6 medium cavities, 4 of them are now equipped with helium tank.
- Three cavities have been successfully assembled with power couplers, they are assembled on the string.
- For P01 and P02 Q-E curves are above specifications even with field emission.
- P03 has not reached ESS specification but is field emission.
- P04 also shows field emission, we are currently working on HPR and clean room operation.

We keep working on the remaining prototypes in order to have the best recipe for cavity series and *High beta cryomodule demonstrator*

THANK YOU FOR YOUR ATTENTION

Thanks to: D. Roudier, L. Maurice, X. Hanus, F. Peauger, P. Bosland, C. Madec, F. Eozenou, C. Servouin, Y. Boudigou, G. Monnereau, E. Jacques, J-P. Charrier, P. Sahuquet, P. Carbonnier, J. Pluoin, G. Devanz.
